

#17/c PA  
w/e  
**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116 11-27-03**  
**EXPEDITED PROCEDURE**  
**TECHNOLOGY CENTER ART UNIT 2825**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Satoshi TAKANO

Group Art Unit: 2825

Application No.: 09/819,690

Examiner: G. Lee

Filed: March 29, 2001

Docket No.: 109107

For: SEMICONDUCTOR MANUFACTURING METHOD, SUBSTRATE PROCESSING  
METHOD, AND SEMICONDUCTOR MANUFACTURING APPARATUS

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the June 3, 2003 Office Action, the shortened statutory period for reply  
being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims;

**Remarks.**

OK to Enter  
as per  
RCE Request of 1/5/04 MMS

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OK TO Enter  
as per RCE  
Request 1/5/04  
MMS

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